



Response Under 37 C.F.R. § 1.116  
Group Art Unit 2815, Expedited Procedure

03500.013630.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASAAKI IWANE ET AL.

Application No.: 09/346,678

Filed: July 2, 1999

For: CRYSTAL GROWTH PROCESS,  
SEMICONDUCTOR DEVICE,  
AND ITS PRODUCTION  
PROCESS

Examiner: J. Diaz

Group Art Unit: 2815

February 28, 2003

Commissioner for Patents  
Box AF  
Washington, D.C. 20231

#25/Amendment  
@11/2/02  
AND...  
3/3/03  
Surber  
4/9/03

TECHNOLOGY CENTER 2800

MAR - 6 2003

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AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action dated December 3, 2002, please amend the  
above-identified application as follows pursuant to 37 C.F.R. 1.116: